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Kikuchi et al.

[11]

[56]

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[54]	PLASMA ASHING METHOD AND APPARATUS THEREFOR			
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[73]	Assignee:	Nihon Shinku Gijutsu Kabushiki Kaisha, Chigasaki, Japan		
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Jar	n. 10, 1989 [J]			
Jar	ı. 10, 1989 [J]	P] Japan 1-2044		
Jar	n. 10, 1989 [J]	P] Japan 1-2045		
[51]	Int. Cl.5	Н04В 7/00		
[52]	U.S. Cl			
		156/345; 156/643; 156/646; 204/164;		
		204/192.1; 219/121.11; 219/121.36;		
		219/121.37; 219/121.4; 219/390		
[58]	Field of Se	arch 156/643, 646, 668, 345;		

204/192 E, 164, 298; 373/40, 18, 22, 62; 219/10.55 E, 10.55 M, 10.67, 121.43, 390,

121.11, 121.36, 121.37, 121.4, 121.41, 383

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Attorney, Agent, or Firm-Armstrong & Kubovcik

ABSTRACT

In a method for plasma ashing a resist film coated on a substrate, the temperature of the substrate is controlled initially at temperatures below that at which explosion of the resist film occurs until a surface portion of a resist film has been removed. Thereafter, the substrate temperature is increased to remove the remaining portions of the resist film. An apparatus for conducting the method includes a plurality of supports, which may be movably disposed within a vacuum treatment chamber for moving the substrate away from a source of heat and for moving the substrate into contact with the heating source.

8 Claims, 10 Drawing Sheets

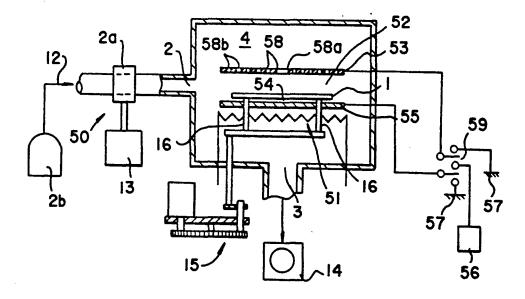
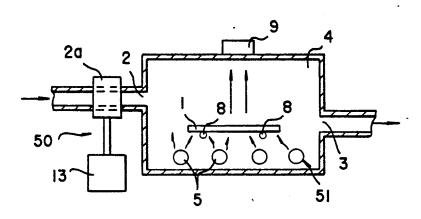
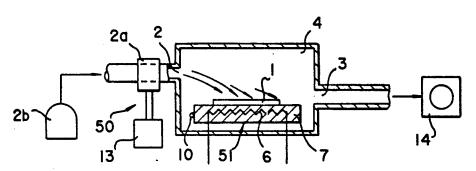


FIG.I PRIOR ART



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FIG.2 PRIOR ART



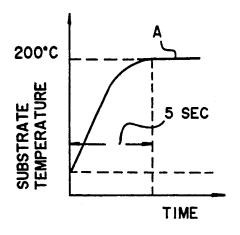


FIG.3 PRIOR ART

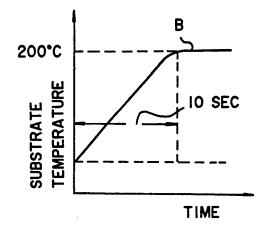


FIG.4 PRIOR ART

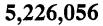


FIG.5 PRIOR ART

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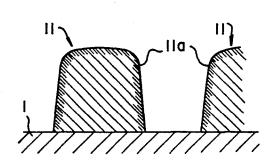
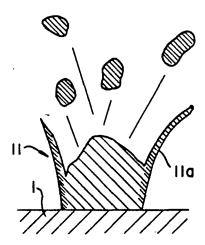
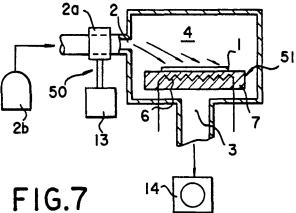
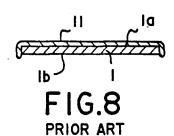


FIG.6 PRIOR ART







PRIOR ART

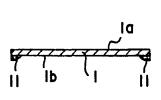


FIG.9 PRIOR ART

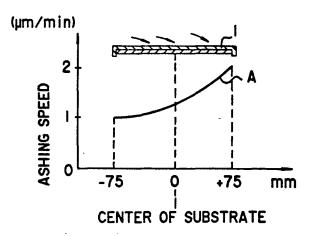
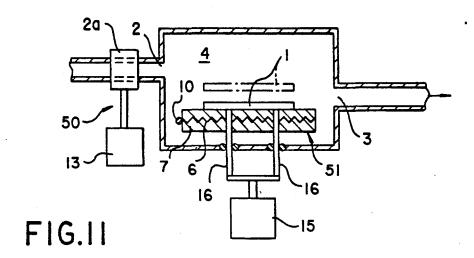
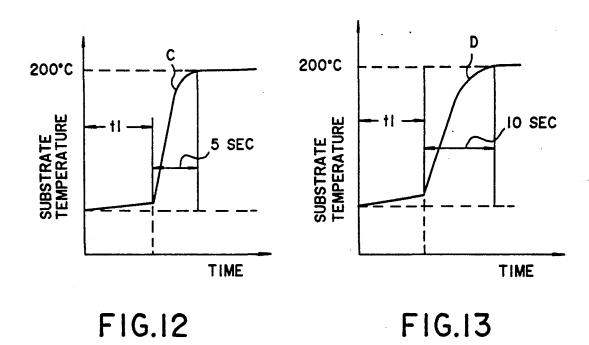
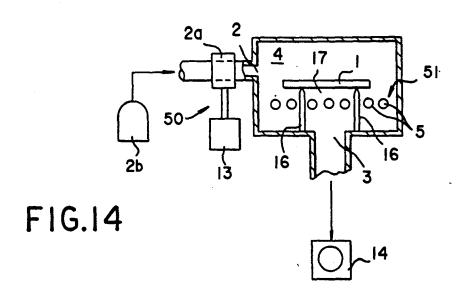


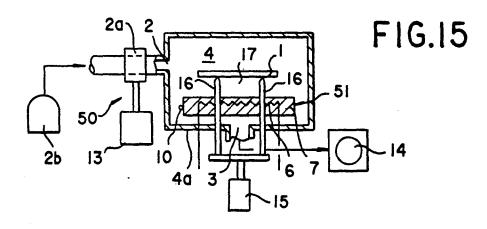
FIG.10 PRIOR ART

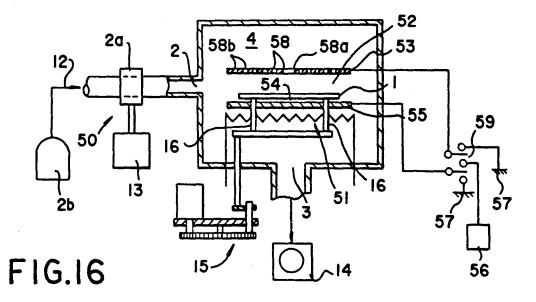






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